

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Applicant: Alexander Hauser et al.

Serial No.: 10/555,141

Filed: October 31, 2005

Title: METHOD FOR TEXTURING  
SURFACES OF SILICON  
WAFERS

Group Art Unit: 2812

Examiner: Mohsen Ahmadi

Docket No.: RAC0082

Conf. No.: 2898

Customer No.: 00832

CERTIFICATE UNDER 37 C.F.R. 1.8(b)

I hereby certify that this correspondence is being electronically submitted to the United States Patent and Trademark Office to the attention of: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Anthony Niewyk, Reg. No. 24,871

Name of Registered Representative

  
Signature

June 21, 2006

Date

AMENDMENT

Mail Stop Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated March 24, 2006, please amend the application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 4 of this paper.